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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:

William Dale Jones

Serial No.: 10/680,783

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For: **HIGH-PRESSURE PROCESSING
CHAMBER FOR A
SEMICONDUCTOR WAFER**

) Group Art Unit: 1765

) Examiner:

) **TRANSMITTAL LETTER**

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Sir:

Enclosed please find a Request to Rescind Previous Non-Publication Request under 35 U.S.C. 122(b) for filing with the U.S. Patent and Trademark Office.

The Commissioner is authorized to charge any additional fee or credit any overpayment to our Deposit Account No. 08-1275. **An originally executed duplicate of this transmittal is enclosed for this purpose.**

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 10-1-04

By:

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CERTIFICATE OF MAILING (37 CFR§ 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

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